

Ivanov Vyacheslav A.

Course Schedule

WEDNESDAY

10:15 — 11:00	■	LEC	Applications of High-frequency Plasma in Technology	👥 M19-208, M20-208	📍 ДОТ
11:05 — 12:40	■	SEM	Applications of High-frequency Plasma in Technology	👥 M19-208, M20-208	📍 ДОТ